pgr

| Notice of Allowability | Application No. | Applicant(s) | |
|--|---|--|---------------------------|
| | 10/786,299 | MCCLURE, BRENT A. | |
| | Examiner | Art Unit | |
| | Lee, Calvin | 2818 | |
| The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313 | (OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to | olication. If not include will be mailed in due | ed course. THIS |
| 1. X This communication is responsive to Remark dated November 4, 2005. | | | |
| 2. ☑ The allowed claim(s) is/are <u>1-21,39-43</u> . | | | |
| 3. ☑ The drawings filed on <u>2/26/04</u> are accepted by the Examiner. | | | |
| 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) | | | |
| each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d). 7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. | | | |
| Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/C Paper No./Mail Date | 5. Notice of Informal P 6. Interview Summary Paper No./Mail Dat 7. Examiner's Amendn 8. Examiner's Stateme 9. Other | (PTO-413), le <u>hereto</u> . nent/Comment | · |
| David Nelms | | | |
| Supervisory Patent Examiner Technology Associated States and State | | | |
| Technology Centar 2800 | | | |

Docket: M4065.0984/P984

Brent A. McCLURE

OFFICE ACTION

Examiner's Amendment

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312:

Claim 11, line 10, after "charge collection region" insert --to form a doped area in said charge collection region--

Claim 11, line 11, after "within said slot" insert --, the contact being in electrical connection to said charge collection region--

Claim 39, line 8, after "floating diffusion region" insert --to form a doped area in said floating diffusion region--

Claim 39, line 9, after "floating diffusion region" insert --, the contact being in electrical connection to said floating diffusion region--

Authorization for this examiner's amendment was given in a telephone interview with Megan S. Woodworth on November 17, 2005.

Allowable Subject Matter

2. Claims 1-21 and 39-43 are allowed. Following is the reason for allowance:

The closest prior art, US 2005/0023553 to *Rhodes*, does not disclose, *inter alia*, forming a slot in a passivation layer in an area over a floating diffusion region of a pixel sensor cell.

3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance.

Page 3

Application No: 10/786,299

Docket: M4065.0984/P984

Brent A. McCLURE

Contact Information

4. Any inquiry concerning this communication from the Examiner should be directed to Calvin Lee at (571) 272-1896 on Mondays thru Thursdays 6:30-4:30 (EST). If attempts to reach the examiner by telephone are unsuccessful, Art Unit 2818's Supervisory Patent Examiner David Nelms can be reached at (571) 272-1787. The central fax number for the organization (where this application is assigned to) is (571) 273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system at http://pair-direct.uspto.gov. Should you have questions on access to the PAIR system, contact the Electronic Business Center at (866) 217-9197.

9

David Nelms Supervisory Patent Examiner Technology Center 2800

Dated: November 17, 2005